



Introduction to Picosecond Laser Tutorial

CMC Laboratories, Inc.



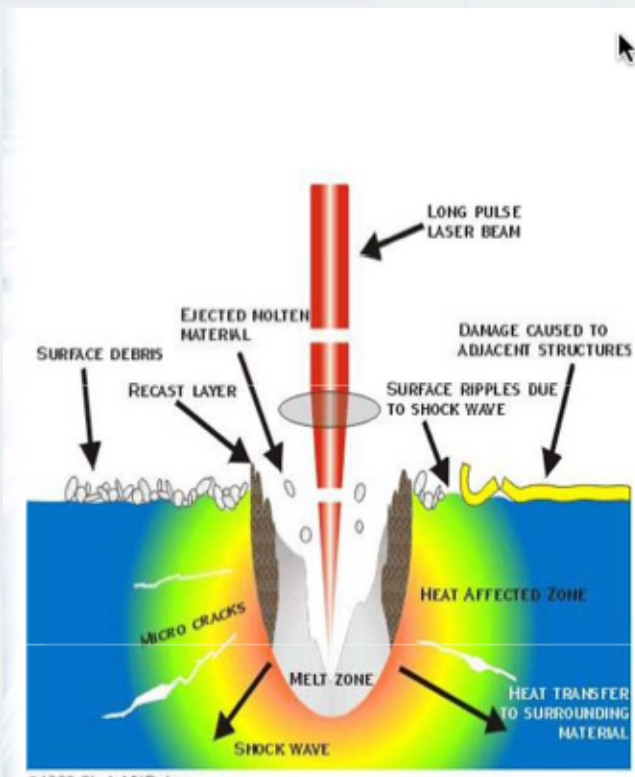
Pico-second

- Ultra-short light pulses
- 1 picosecond is 10^{-12} seconds
- Light travels 300,000,000 meters per second, in 3 picoseconds it travels 1 mm



Why Process with Ultra-Short Pulses?

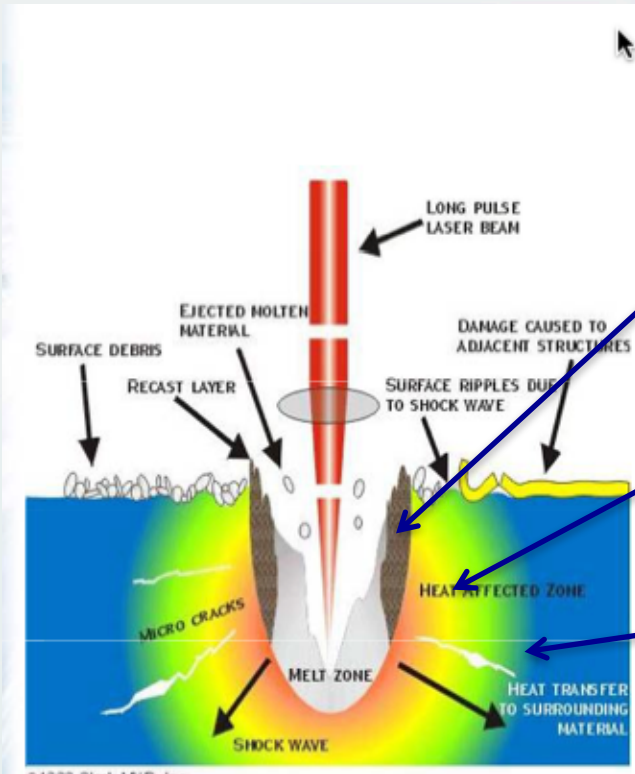
- Long laser pulse processing (typically 10 nanoseconds or longer)
 - High average power, low peak power
 - Thermal drilling (drill by injecting heat into the substrate at the drill site)
 - Injected heat melts and vaporizes the substrate material



Schematic- Thermal Drilling Process



Issues with thermal drilling

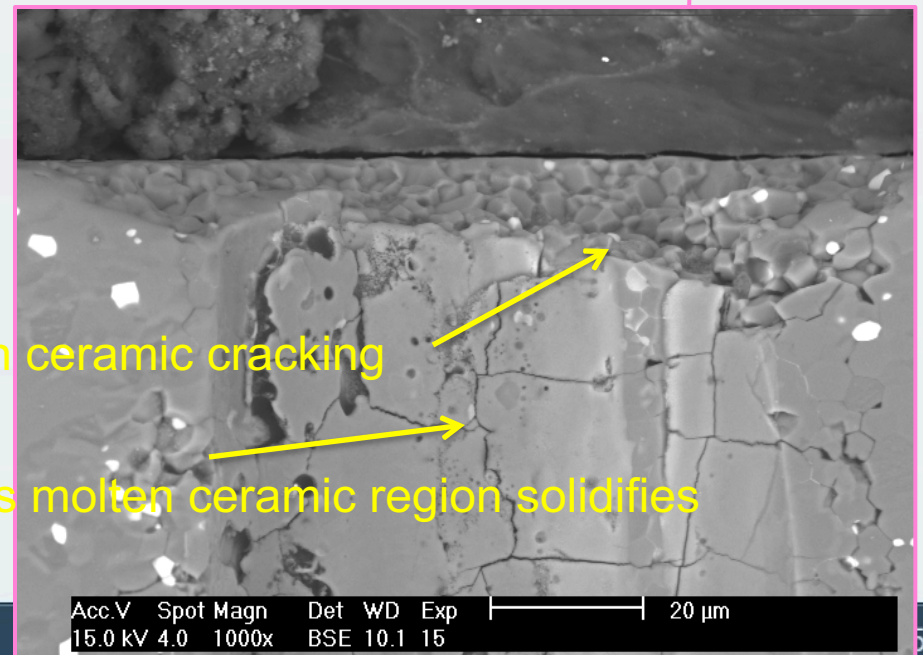
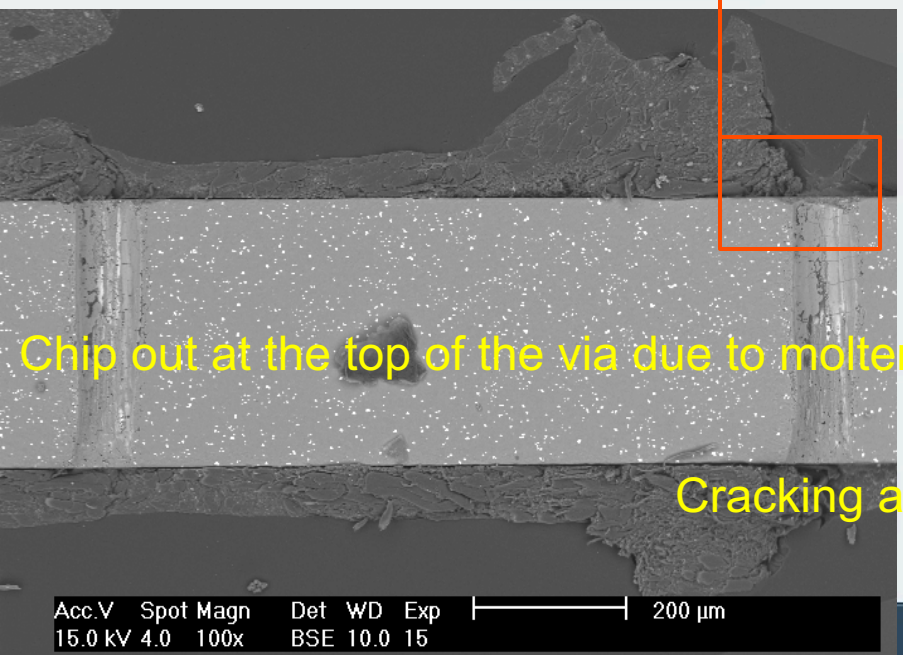
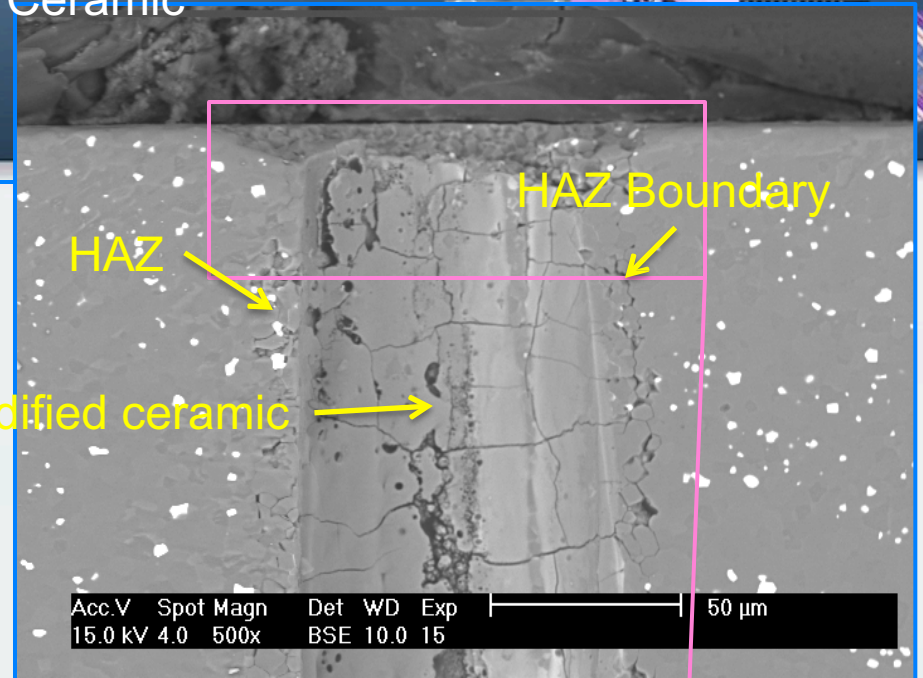
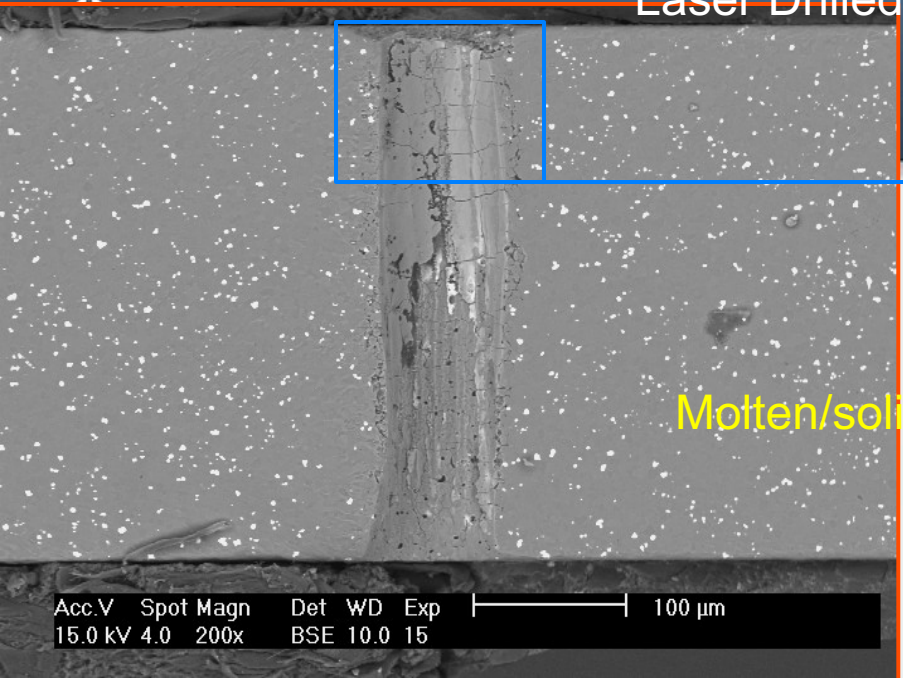


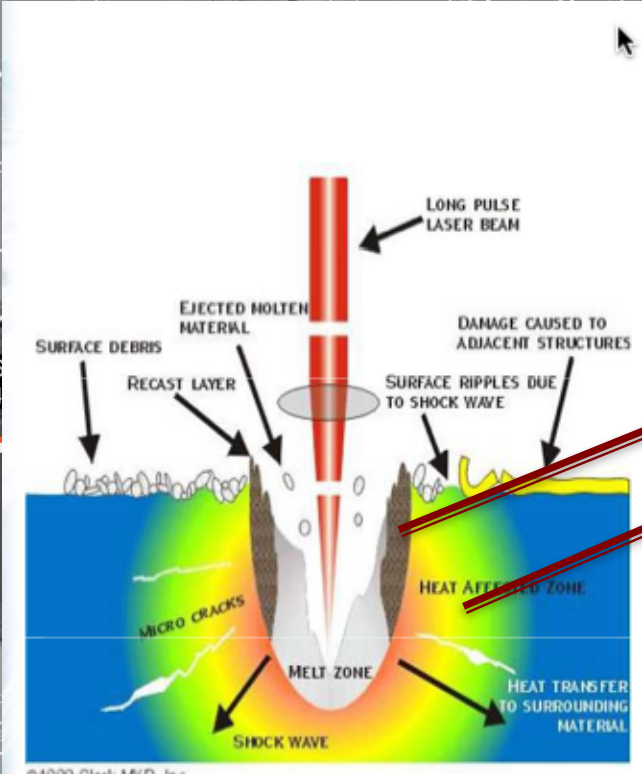
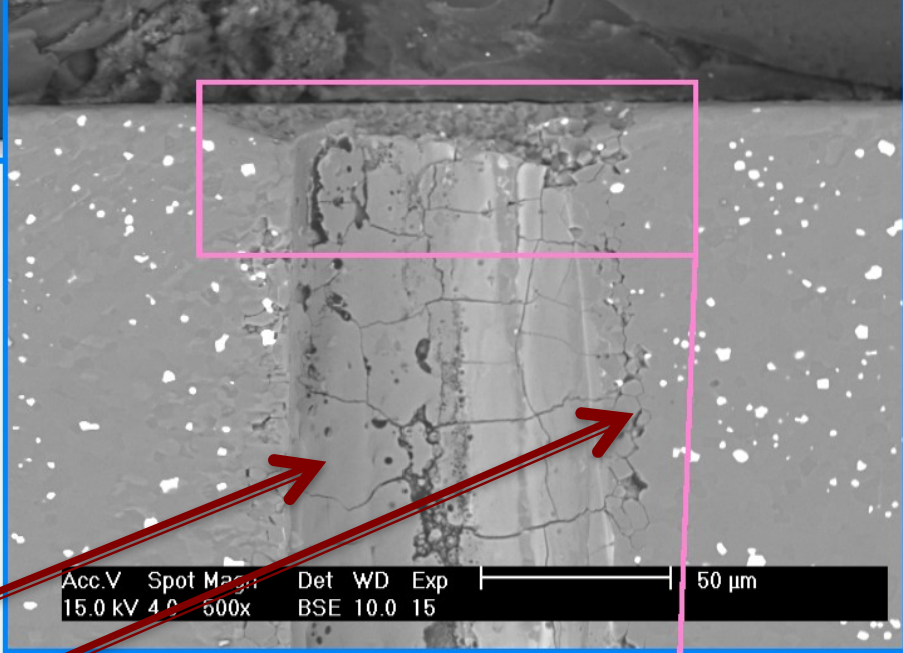
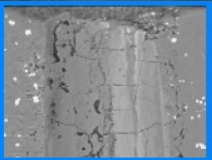
Build up of solidified and vapor deposited material inside the drill site and around the edges: **LASER SLAG** → Metallization failures as slag breaks off

Areas around the drill site heat up enough to change microstructure- **HEAT EFFECTED ZONE (HAZ)** → Metal failures and pores which can cause blistering

At the interface between the HAZ and non-heated areas there is a large CTE stress from expansion of HAZ which can result in cracks → **Surface blisters or cracks that propagate**

Laser Drilled Ceramic

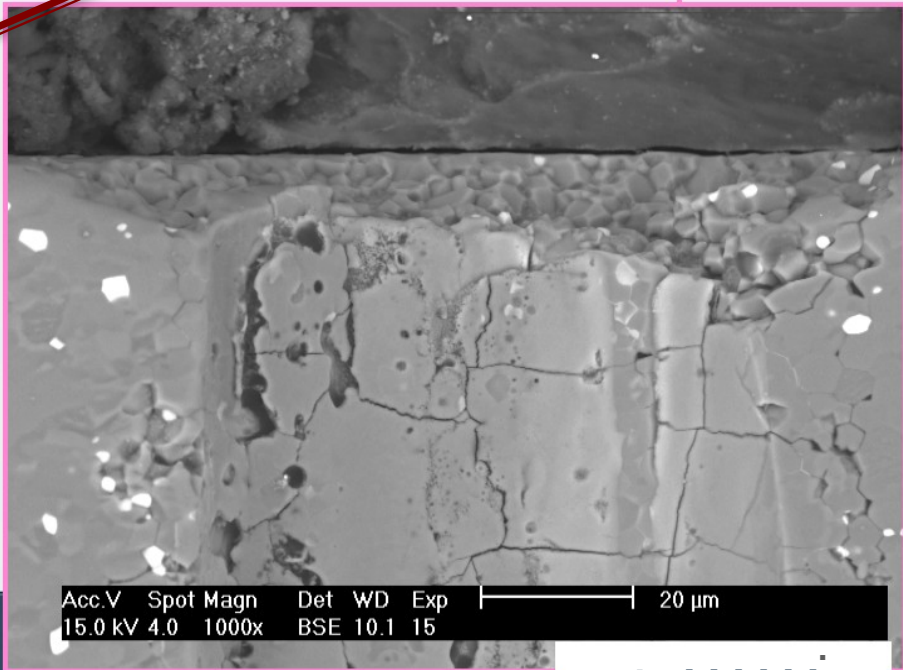




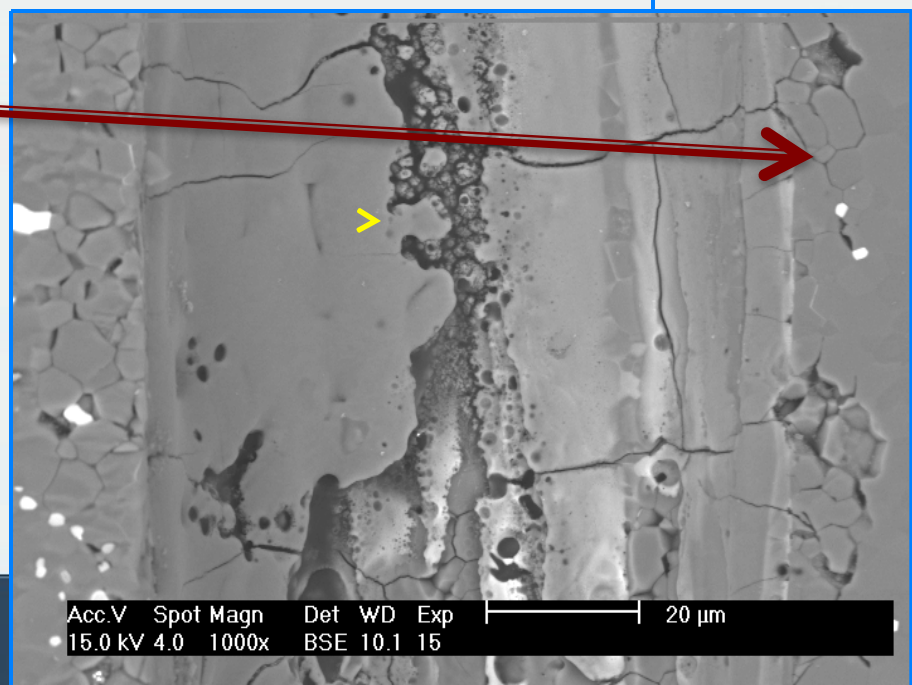
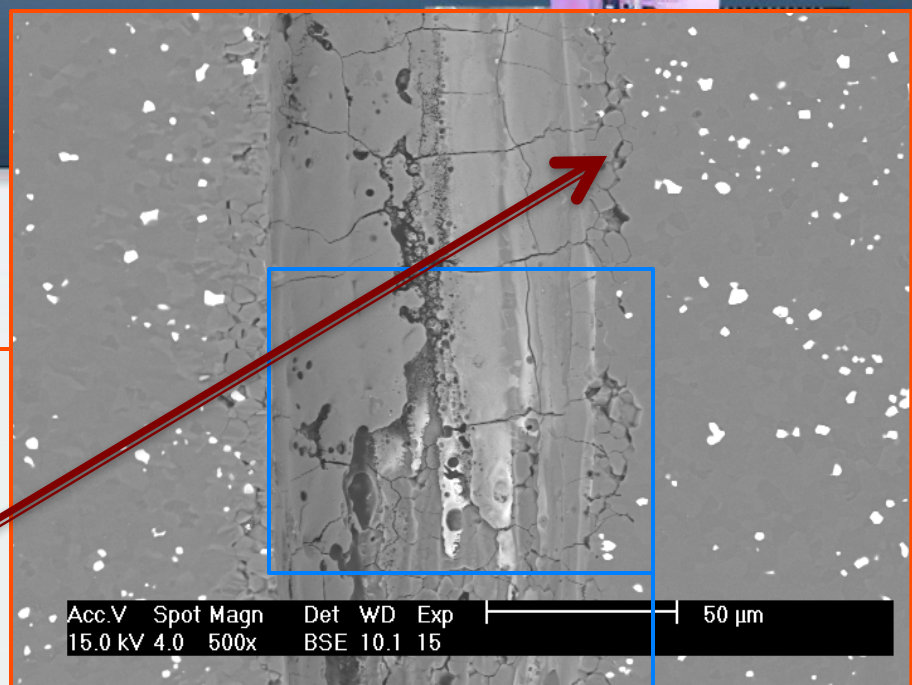
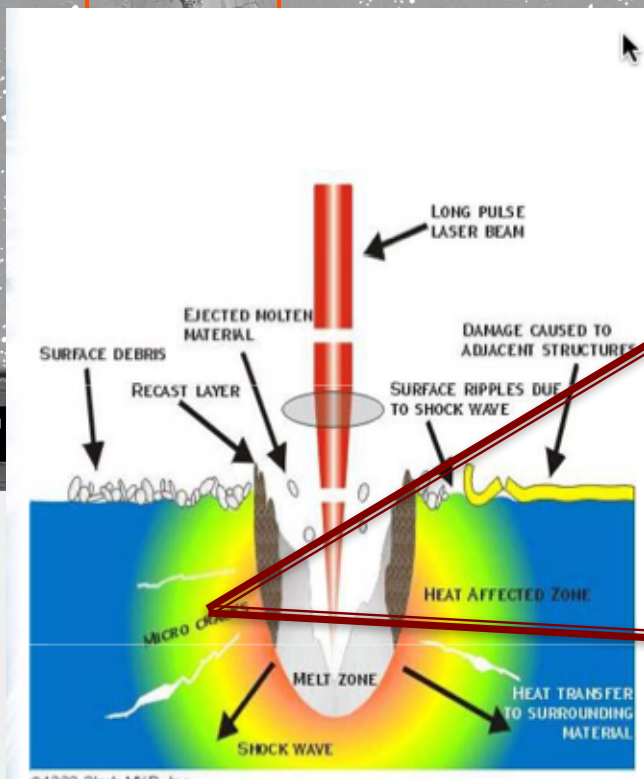
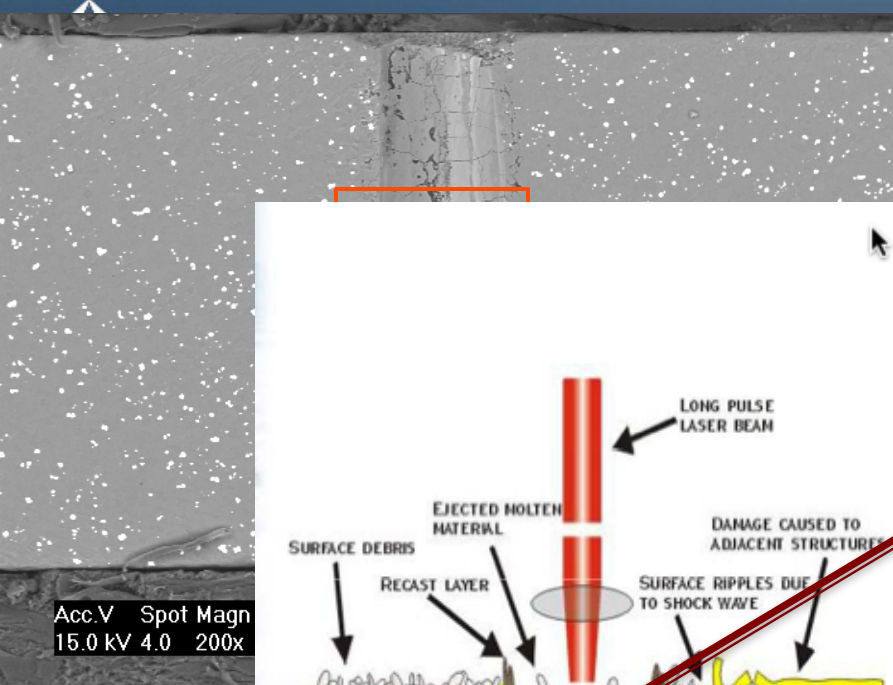
Acc.V S
15.0 kV 4

Acc.V	Spot Magn	Det	WD	Exp	50 μm
15.0 kV	4.0	BSE	10.0	15	

Acc.V	Spot Magn	Det	WD	Exp	200 μm
15.0 kV	4.0	BSE	10.0	15	



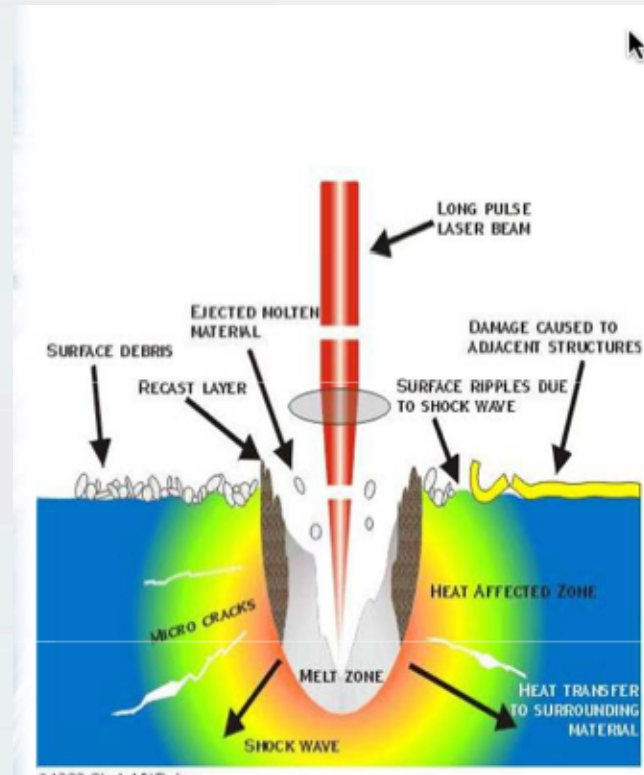
Acc.V	Spot Magn	Det	WD	Exp	20 μm
15.0 kV	4.0	BSE	10.1	15	



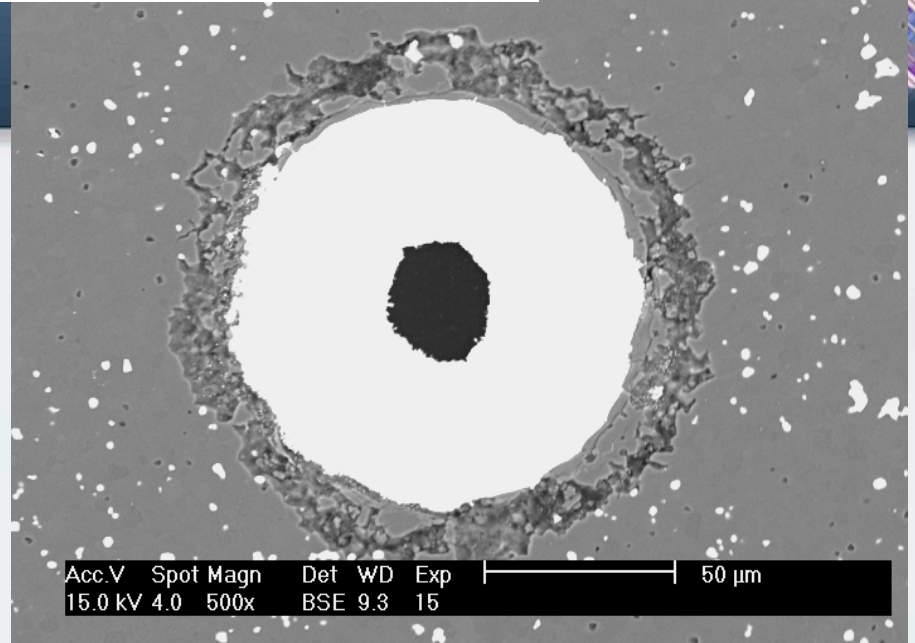
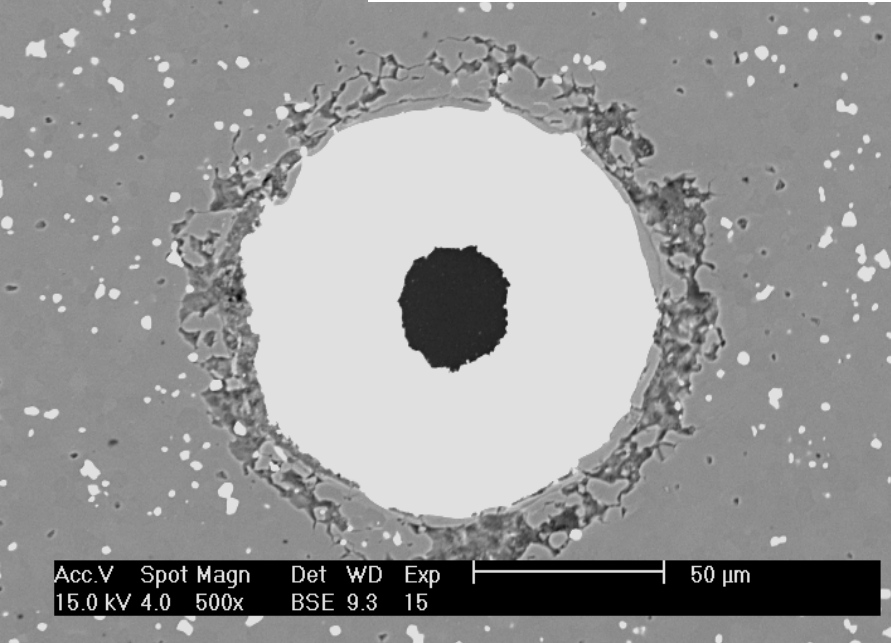


Observations from Cross Sections

- Re-caste zone where molten ceramic re-solidifies and cracks
- HAZ formation
- Cracking at HAZ/non HAZ interface



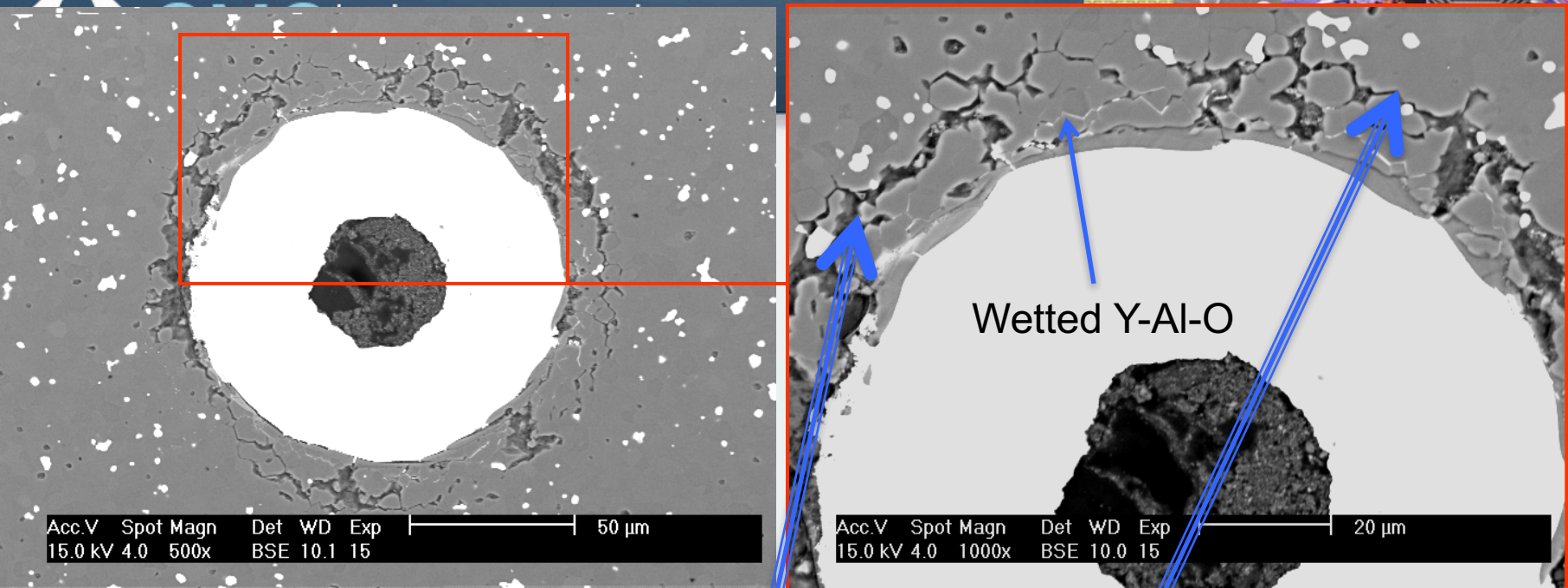
SEM Planar Photos of Top of Via



Optical Photos of Top Surface for AlN Part



SEM Planar Photos of Top of Via after Vacuum Impregnation with Epoxy and Re-Polishing



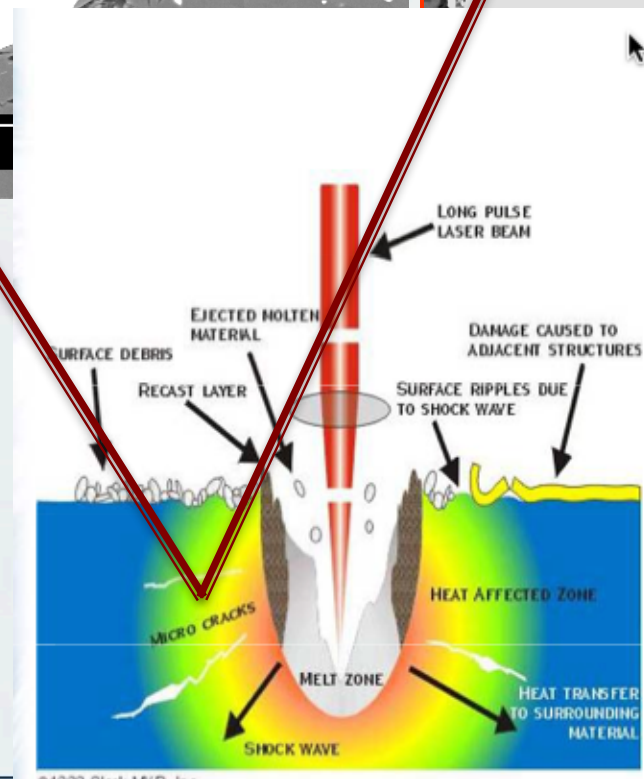
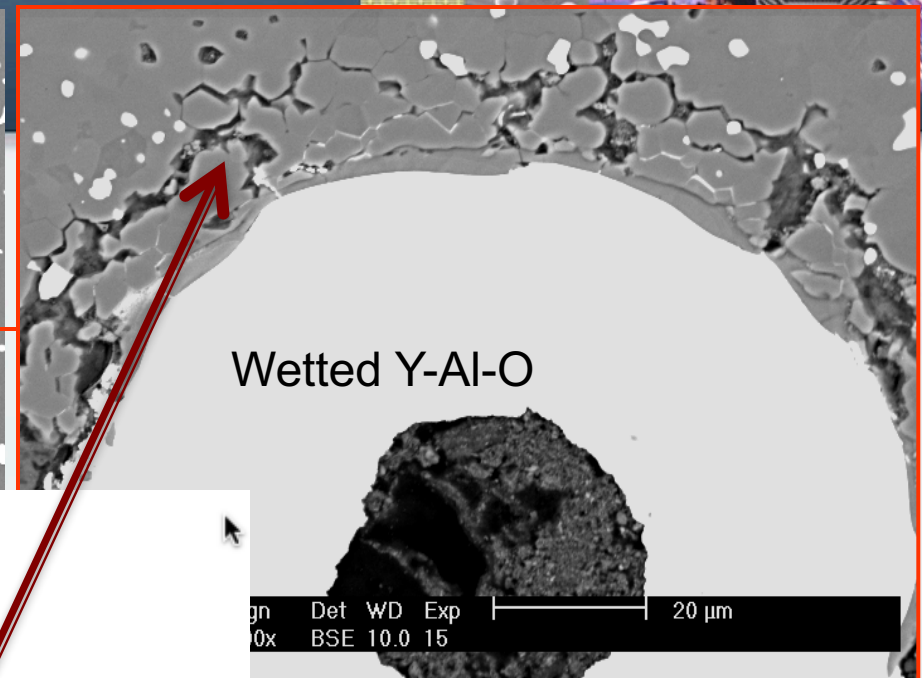
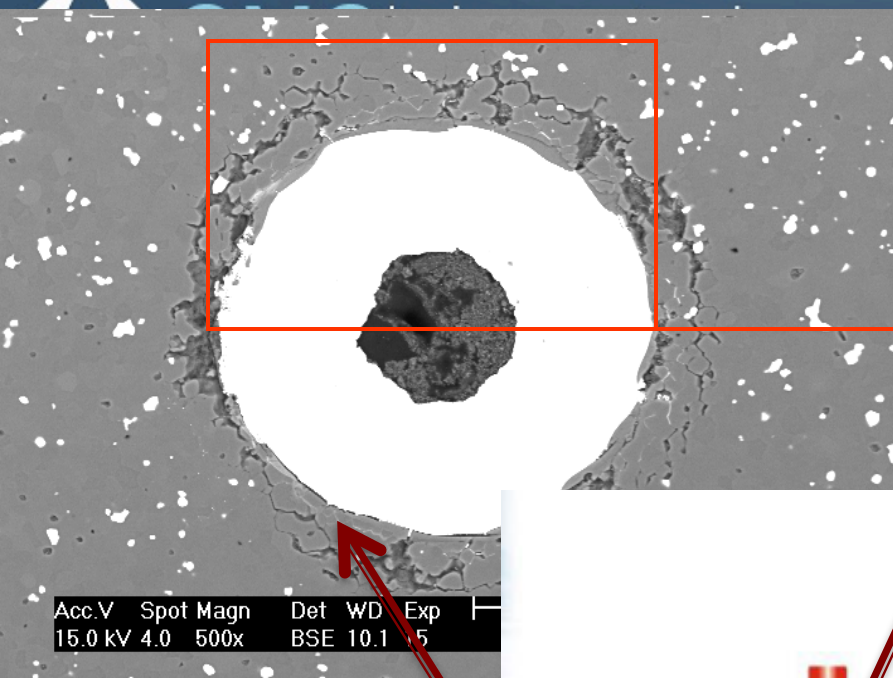
Cracking in HAZ

HAZ Boundary

Drilling is thermal (melt/vaporize) vs. direct vaporization

- Average power is too high
- Peak power may be too low
- Use shorter laser pulses if possible to increase peak power and decrease average power

SEM Planar Photos of Top of Via after Vacuum Impregnation with Epoxy and Re-Polishing



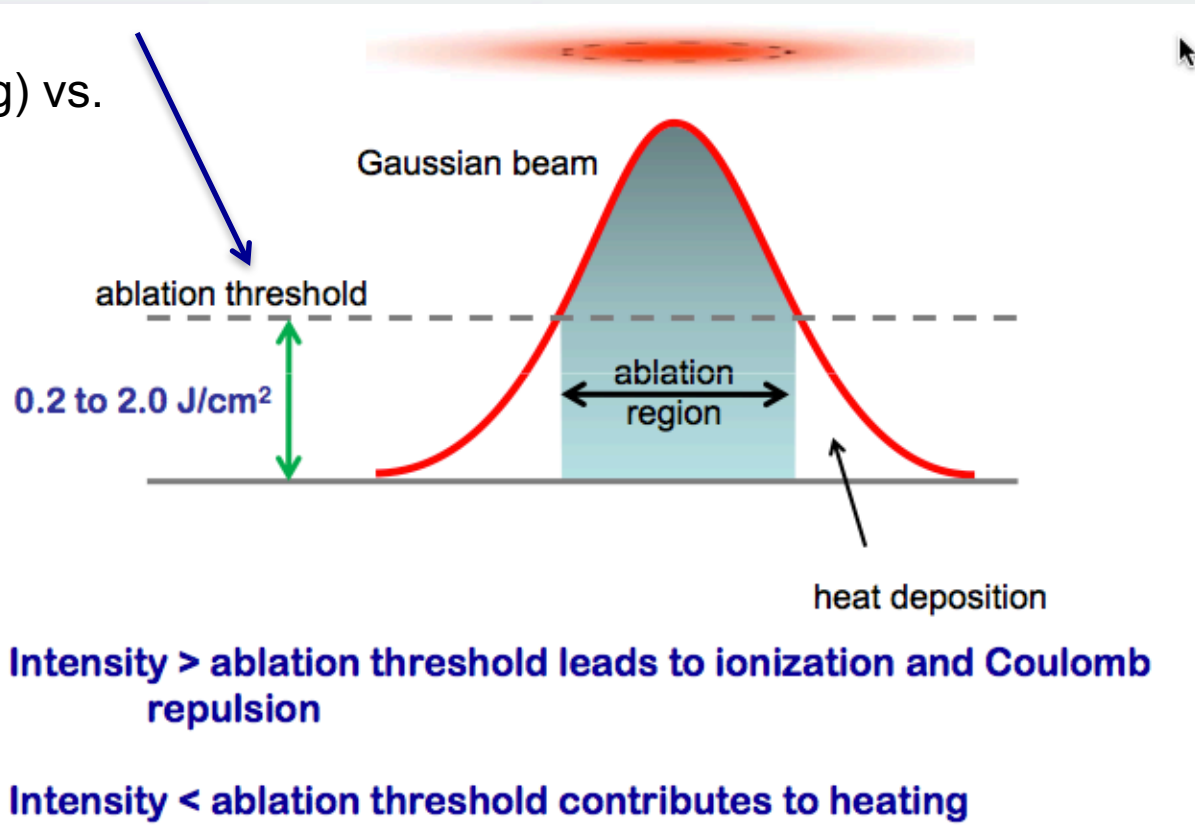


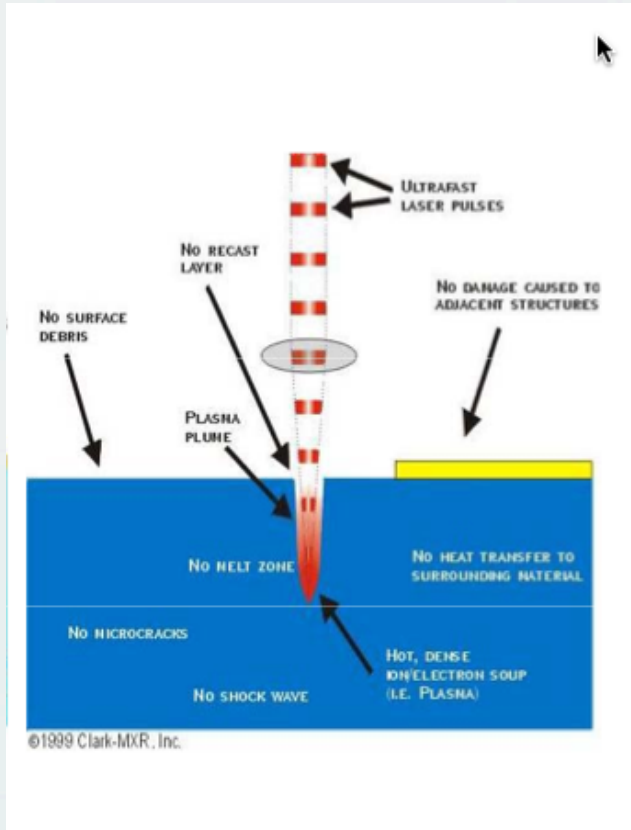
Why Process with Ultra-Short Pulses

- 10 femtosecond (10^{-14} seconds) to 10 nanoseconds (10^{-8} seconds) which includes the picosecond regime
- Very high peak power, very low average power
- Drill without heat and without melting the substrate using “cold ablation”
- Substrate material is directly converted into a plasma



Threshold of laser pulse energy to create plasma (ablation drilling) vs. thermal drilling





No heat transfer to surrounding material → NO HAZ FORMATION AND NO CRACKING AT HAZ/ NON HAZ INTERFACE

No melting or vaporizing of substrate → NO SLAG ON SURFACE OR WITHIN THE VIA

Key sacrifice for improved quality → LOWER DRILLING SPEED



Laser Drill with NO HEAT



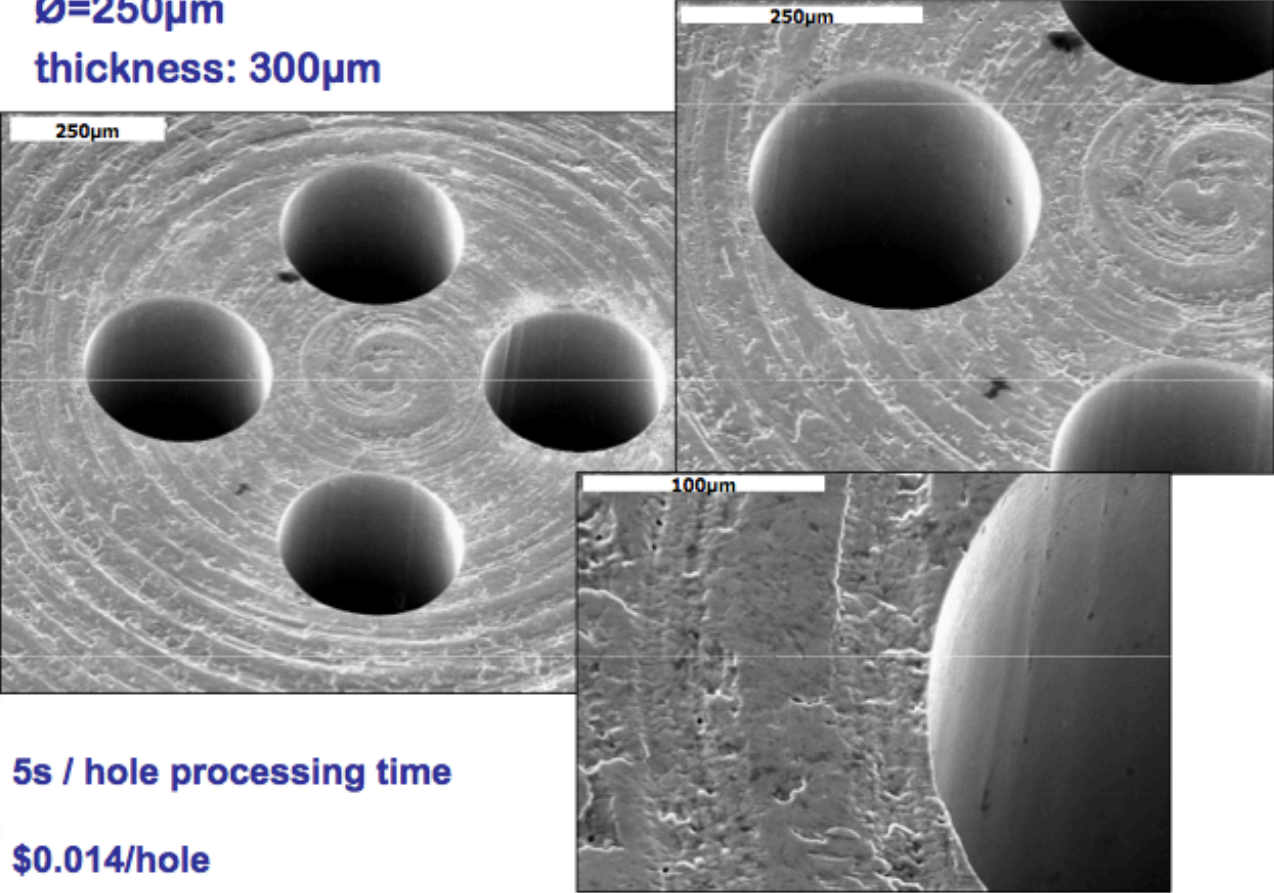


Examples of Materials Drilled with Picosecond Pulses



Drilling Stainless Steel

$\text{\O} = 250\mu\text{m}$
thickness: $300\mu\text{m}$



250µm

250µm

100µm

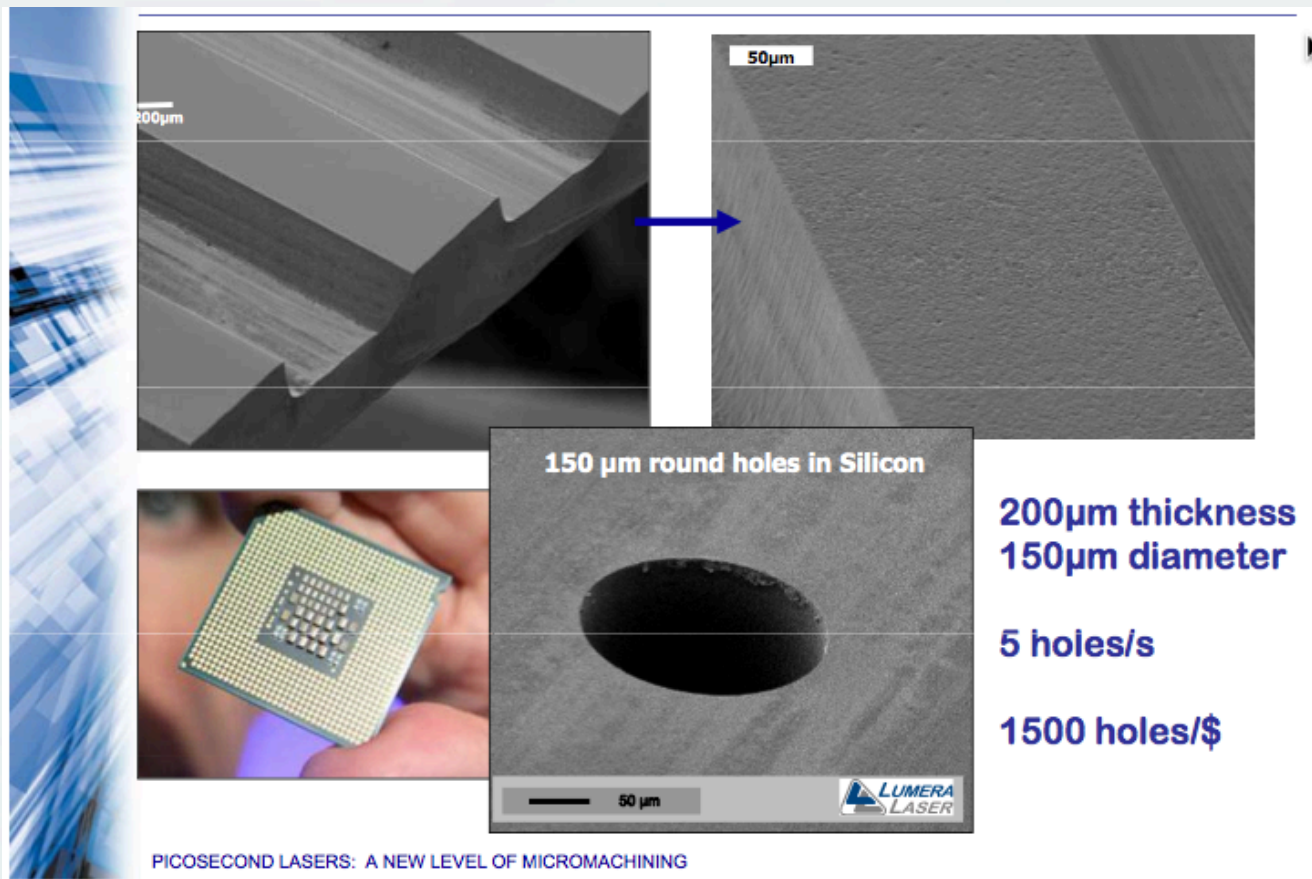
5s / hole processing time

\$0.014/hole

PICOSECOND LASERS: A NEW LEVEL OF MICROMACHINING



Silicon



200µm

50µm

150 µm round holes in Silicon

200µm thickness
150µm diameter

5 holes/s

1500 holes/\$

50 µm

LUMERA LASER

PICOSECOND LASERS: A NEW LEVEL OF MICROMACHINING



Picosecond Laser Systems



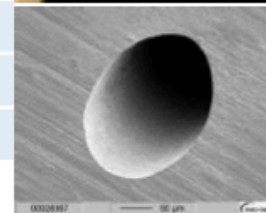
Picosecond Laser Characteristics

TRUMPF



TruMicro Series 5000

	TruMicro 5050	TruMicro 5250	TruMicro 5350
Average Power	50 W	25 W	> 15 W
Wavelength	1030 nm	515 nm	343 nm
Pulse Duration	< 10 ps	< 10 ps	< 10 ps
Max. Pulse Energy	250 μ J	125 μ J	> 75 μ J
Repetition Rate*	200/400 kHz	200/400 kHz	200/400 kHz
Beam Quality	$M^2 < 1.3$	$M^2 < 1.3$	$M^2 < 1.3$

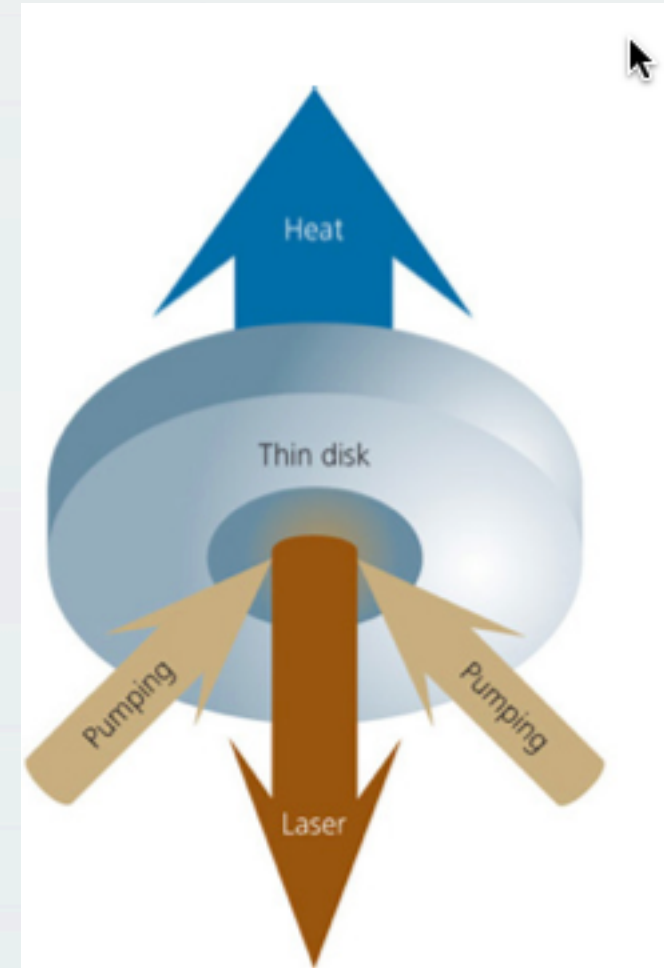


* Higher Repetition Rates upon request



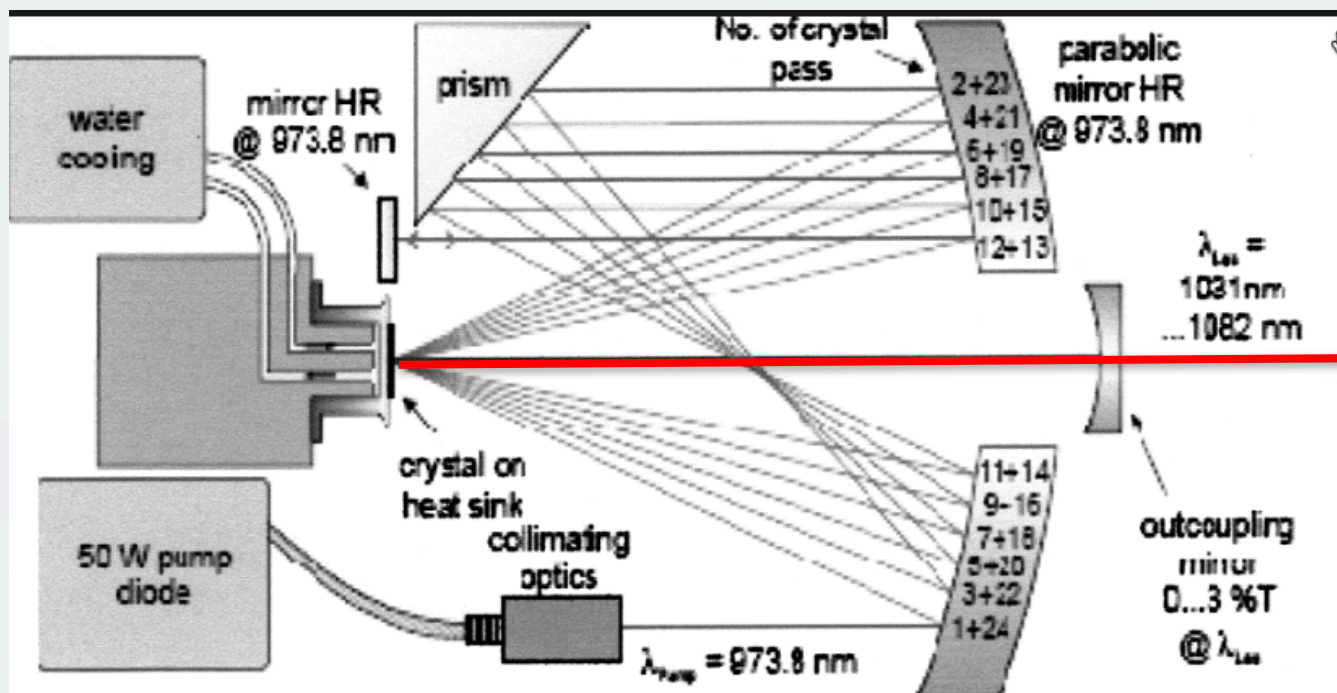
Thin Disc Lasers

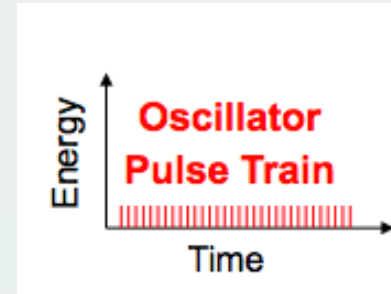
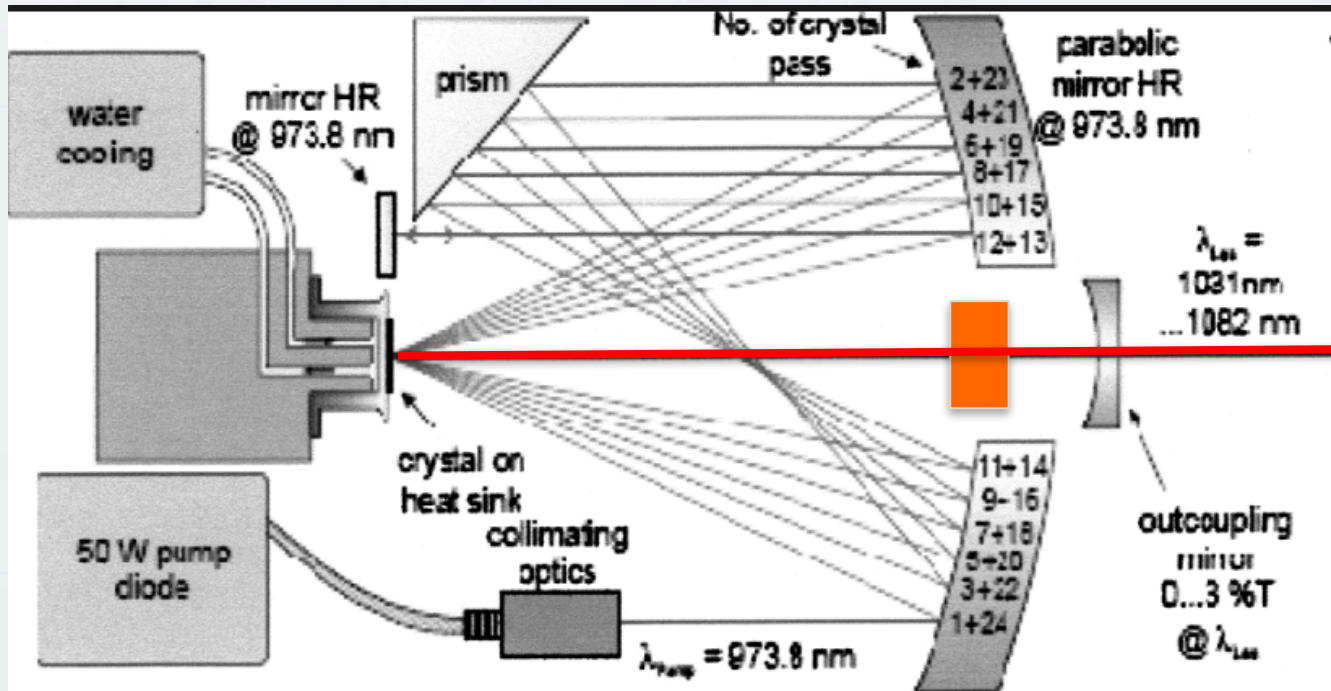
- Gain medium is a thin disc (typically Yb doped YAG Crystal)
- Attached to a heat sink for very efficient heat removal
- Pumped with a diode laser





Pump Laser incident on Yb:YAG disc to provide energy





Crystal Oscillator driven by RF signal inserted in laser cavity. Only certain laser mode are now supported by the cavity, a condition called “mode locked”. This results in a laser output of a stream of short pulses.



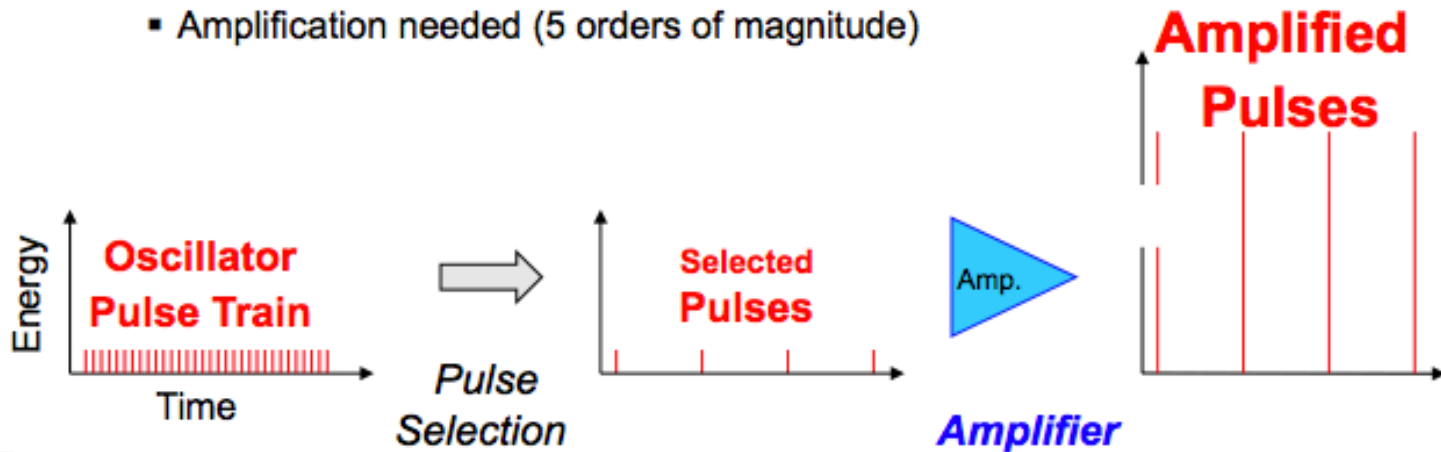
Pulsed laser output is followed by Pulse Selection and Amplifier(s)

Obtaining ps-Pulses

ps (and fs) Oscillators:

- Tens of MHz Repetition Rate (given by resonator length)
- Pulse selection to lower Repetition Rate

- Pulse Energies in nJ scale
- Amplification needed (5 orders of magnitude)





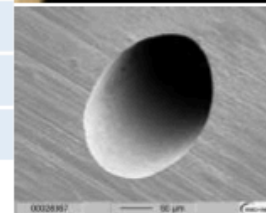
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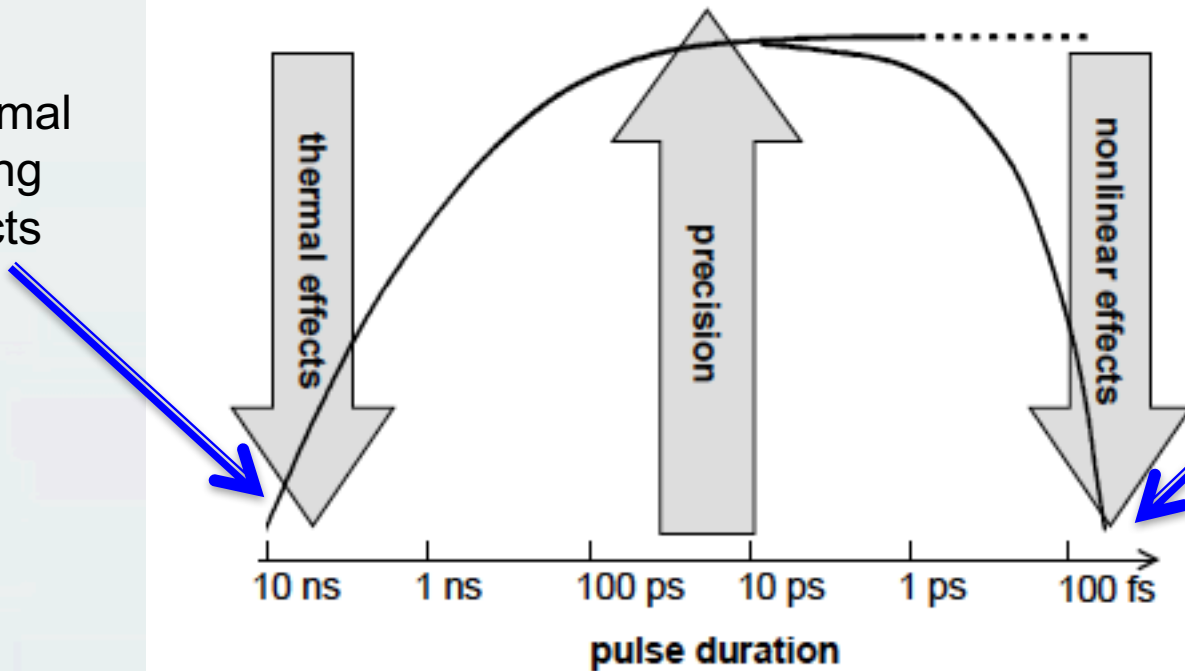


Comparison with Longer Pulse Drilling



Optimum Range: 10-100 ps

Thermal Drilling Effects



Peak powers so high that non-linear optical effects start to occur

Figure 17 Precision depending on pulse duration in drilling of metals



Shorter Pulses- Longer Drill Times (for Fixed Frequency and Pulse Energy)

In this example:
 20 ns is 1 $\mu\text{m}/\text{pulse}$
 100 ns is 7 $\mu\text{m}/\text{pulse}$

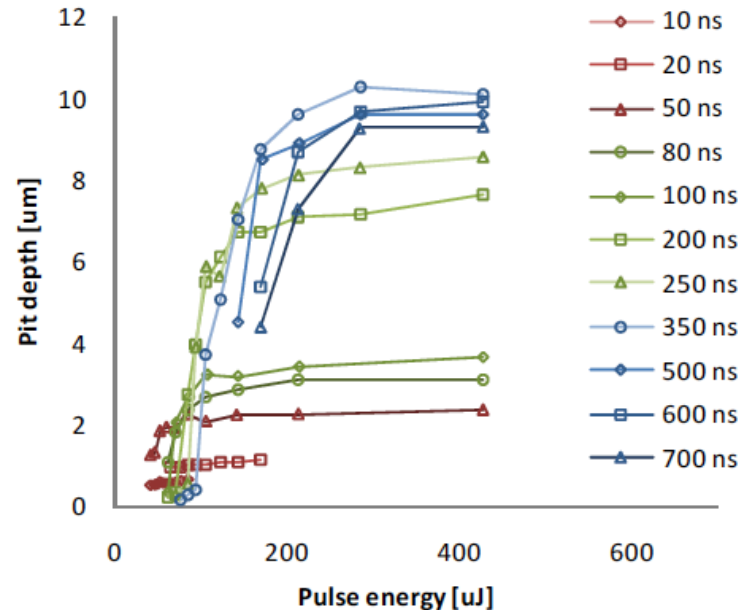


Figure 5. Pit depth as a function of the pulse energy for different pulse durations



Summary

- Picosecond pulse width => optimum for hole quality
 - Cold ablation with minimal thermal effects
 - Minimize: slag, HAZ formation, cracking at HAZ interface
- Trade off with slower drilling speed
 - Material removal per pulse scale with pulse energy
 - Shorter pulse, higher peak energy, lower pulse energy
 - 50W ps laser could be 10x slower than CO2 laser at same frequency